

03500.017757.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
HIDEYA KUMONI	:	Examiner: Not Yet Assigned
)	
Application No.: Not Yet Assigned	:	Group Art Unit: Not Yet Assigned
)	
Filed: Herewith	:	
)	
For: PROCESS FOR PRODUCING	:	
CRYSTALLINE THIN FILM	:	May 17, 2005

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

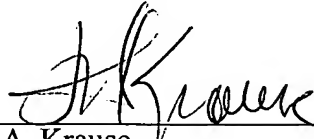
In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the non-U.S. documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed.

The listed documents were cited in a PCT International Search Report mailed June 3, 2004 for International Application No. PCT/JP03/15717, which is the parent of the present application from which this application claims priority. A copy of each of this search report is also enclosed.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicant's undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



John A. Krause
Attorney for Applicant
Registration No.: 24,613

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3800
Facsimile: (212) 218-2200

NY_MAIN 501174v1

LIST OF REFERENCES CITED BY APPLICANT(S)
(Use several sheets if necessary)

ATTY DOCKET NO.

03500.017757.

APPLICATION NO.

NOT YET ASSIGNED

APPLICANT

HIDEYA KUMONI

FILING DATE

HEREWITH

GROUP

NOT YET ASSIGNED

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		4,564,403	01/14/86	Hayafuji et al.	148	171	
		4,822,752	04/18/89	Sugahara et al.	437	174	
		6,346,462 B1	02/12/02	Jung	438	486	

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
	EP	1 262 578 A1	12/04/02	EPO			Yes
	WO	01/18854 A1	03/15/01	WIPO			Yes
	WO	02/086954 A1	10/31/02	WIPO			Yes

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)

		Fortunato G., et al. "Excimer Laser Crystallization Techniques for Polysilicon TFTs", Applied Surface Science, vol. 154-155, pp. 95-104, February 2000.

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.